



GAU 2811

PATENT APPLICATION
Do. No. 5484-48

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Byung-Sup SHIM et al.**

Serial No. 09/305,240

Examiner:

O. Nadav

Filed: May 4, 1999

Group Art Unit:

2811

For: **OPEN DRAIN INPUT/OUTPUT STRUCTURE AND MANUFACTURING
METHOD THEREOF IN SEMICONDUCTOR DEVICE**

Date: March 9, 2000

Box Non-Fee Amendment
Commissioner of Patents and Trademarks,
Washington, D.C. 20231

RESPONSE TO RESTRICTION REQUIREMENT

Responsive to the Office Action, dated February 17, 2000, please amend the application as follows.

IN THE CLAIMS:

Applicant elects claims 5-9, drawn to a semiconductor device, without traverse.

REMARKS

Applicant respectfully submits that each of the Examiner's rejections have been overcome and that this Application is in condition for allowance. Such is respectfully requested.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231

Date: March 9, 2000

By Derek S. Watson
Derek S. Watson

Respectfully submitted,

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